Se	arch No	otes	

Application/Control No.	Applicant(s)/Patent under Reexamination
10/814,033	TSENG ET AL.
Examiner	Art Unit
Kim M. Lewis	3743

SEARCHED				
Class	Subclass	Date	Examiner	
602	41-59	9/14/2005	KML	
128	888,889	1	1	
2	21			
2	161			
2	161.3			
2	161.2			
2	161.6			
2	161.8	9/14/2005	KML	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

DATE	EXMR
	LVIVIX
9/12/2005	KML
9/13/2005	KML
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